

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Applicant: Wang, et al

Docket Number: TI-34402 (102521.00324)

Serial No.: Not Yet Assigned

Art Unit: Unknown

Filed: Filed Herewith

Examiner: Unknown

For: CHEMICAL MECHANICAL POLISHING
APPARATUS AND METHOD TO
MINIMIZE SLURRY ACCUMULATION
AND SCRATCH EXCURSIONS

INFORMATION DISCLOSURE STATEMENT

MAIL STOP PATENT APPLICATION
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)
I hereby certify that the above correspondence is being deposited with
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for Patents, P.O. Box 1450, Alexandria, VA 22313-1450
on November 21, 2003.
Express Mail No. EV 312946505 US



Lori Doyle

Dear Sir:

Applicant wishes to bring to the attention of the Patent and Trademark Office the information noted on the enclosed PTO-1449. Copies of the noted referenced are enclosed herewith.

Respectfully submitted,

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